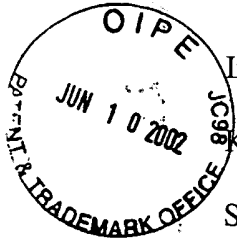


Docket No.: 61282-022

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of

Kenji SHIMAZAKI, et al.

Serial No.: 10/092,737

Group Art Unit: 2857

Filed: March 08, 2002

Examiner:

For: ELECTROMAGNETIC DISTURBANCE ANALYSIS METHOD AND
APPARATUS AND SEMICONDUCTOR DEVICE MANUFACTURING
METHOD USING THE METHOD

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Paper
P. Walker
4-3-03

TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT

Honorable Commissioner for Patents and Trademarks
Washington, D. C. 20231

Sir:

At the time the above application was filed, priority was claimed based on the
following application:

Japanese Patent Application No. P.2001-065105, filed March 8, 2001

A copy of each priority application listed above is enclosed.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202)756-8000 MEF:mlw
Facsimile: (202)756-8087
Date: June 10, 2002